

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:	)	
	)	
Kazuhiro ATSUMI et al.	)	Confirmation No.: 2498
	)	
Application No.: 10/585,451	)	Group Art Unit: 3742
	)	
Filed: May 4, 2007	)	Examiner: John Samuel Wasaff
	)	
For: LASER PROCESSING METHOD	)	
AND DEVICE	)	

Commissioner for Patents  
U.S. Patent and Trademark Office  
**Customer Window, Mail Stop Amendment**  
Alexandria, VA 22314

Sir:

**AMENDMENT**

In response to the Office Action dated August 9, 2010, the period for response to which has been extended through February 9, 2011, by the three-month extension of time petitioned for herein, please amend the above-identified application as follows: